



EP 3723
7-7-01
#4

In re Application of

Douglas Ronald McCarter et al.

Serial No.: 09/778,525

Filed: February 6, 2001

For: METHOD OF FINISHING A
SILICON PART

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Attorney Docket: McCarter-1

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TECHNOLOGY CENTER R3700

**INFORMATION DISCLOSURE STATEMENT
IN ACCORD WITH 37 C.F.R. 1.97**

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant wishes to make record of the reference listed on the enclosed Form PTO-1449. Copies of the references are enclosed herewith.

It is understood that no fee is due in connection with filing the Information Disclosure Statement; however, in the event a fee is found to be due, the Assistant Commissioner is authorized to debit Deposit Account No. 02-4345. This authorization is provided in triplicate.

Respectfully submitted,

Loren G. Helmreich
Reg. No. 29,389

Date: 22 MAY 2001
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<p align="center">CERTIFICATE OF MAILING</p> <p>I hereby certify that this correspondence and all referenced enclosure(s) are being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on May 22, 2001.</p> <p>By: <u></u></p>
